Docket No.: SHIGA7.030APC Customer No. 20.995

## INFORMATION DISCLOSURE STATEMENT

Applicant : Tsuyoshi Nakamura

App. No : 10/553,159

Filed : October 14, 2005

For : RESIN FOR UNDERCOATING

MATERIAL, UNDERCOATING MATERIAL, LAMINATE, AND MULTILAYERED RESIST PATTERN

FORMING METHOD

Examiner : Anca Eoff

Art Unit : 1795

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 2 (two) references to be considered by the Examiner. Also enclosed are 1 (one) foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed before the mailing date of a final action and before the mailing of a Notice of Allowance. This Statement is accompanied by the fees set forth in 37 C.F.R. § 1.17(p). The Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 3/10/08

Nett S Bartfeld, Ph.D. Registration No. 39,901

Agent of Record Customer No. 20,995

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